

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Priority Application Serial No. ....09/438,310  
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Inventor..... Mark A. Helm et al  
Assignee..... Micron Technology, Inc.  
Priority Group Art Unit .....2814  
Priority Examiner ..... S. Rao  
Attorney's Docket No. ....MI22-2478  
Title: Gated Semiconductor Assemblies and Methods of Forming Gated Semiconductor  
Assemblies

**PRELIMINARY AMENDMENT**

To: MS Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS**

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